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In re Patent No. 7,014,958

Issue Date: 3/21/2006

Appl No.: 10/604,181

Filed: June 30, 2003

For: Method for Dry Etching Photomask Material

**DECISION DISMISSING
PETITION
37 CFR 1.324**

This is a decision on the petition under 37 CFR 1.48, filed 3/10/2004. In view of the fact that the patent has already issued, the request under 37 CFR 1.48 has been treated as a petition to correct inventorship under 37 CFR 1.324.

The petition is dismissed.

A petition to correct inventorship as provided by 37 CFR 1.324 requires (1) a statement from each person who is being added as an inventor that the inventorship error occurred without any deceptive intention on their part, (2) a statement from the current named inventors (including any "inventor" being deleted) who have not submitted a statement as per "(1)" either agreeing to the change of inventorship or stating that they have no disagreement in regard to the requested change, (3) a statement from all assignees of the parties submitting a statement under "(1)" and "(2)" agreeing to the change of inventorship in the patent; such statement must comply with the requirements of 37 CFR 3.73(b); and (4) the fee set forth in 37 CFR 1.20(b). **This petition lacks item(s): statements from the current named inventors agreeing to the change of inventorship or stating that they have no disagreement in regard to the requested change.**

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